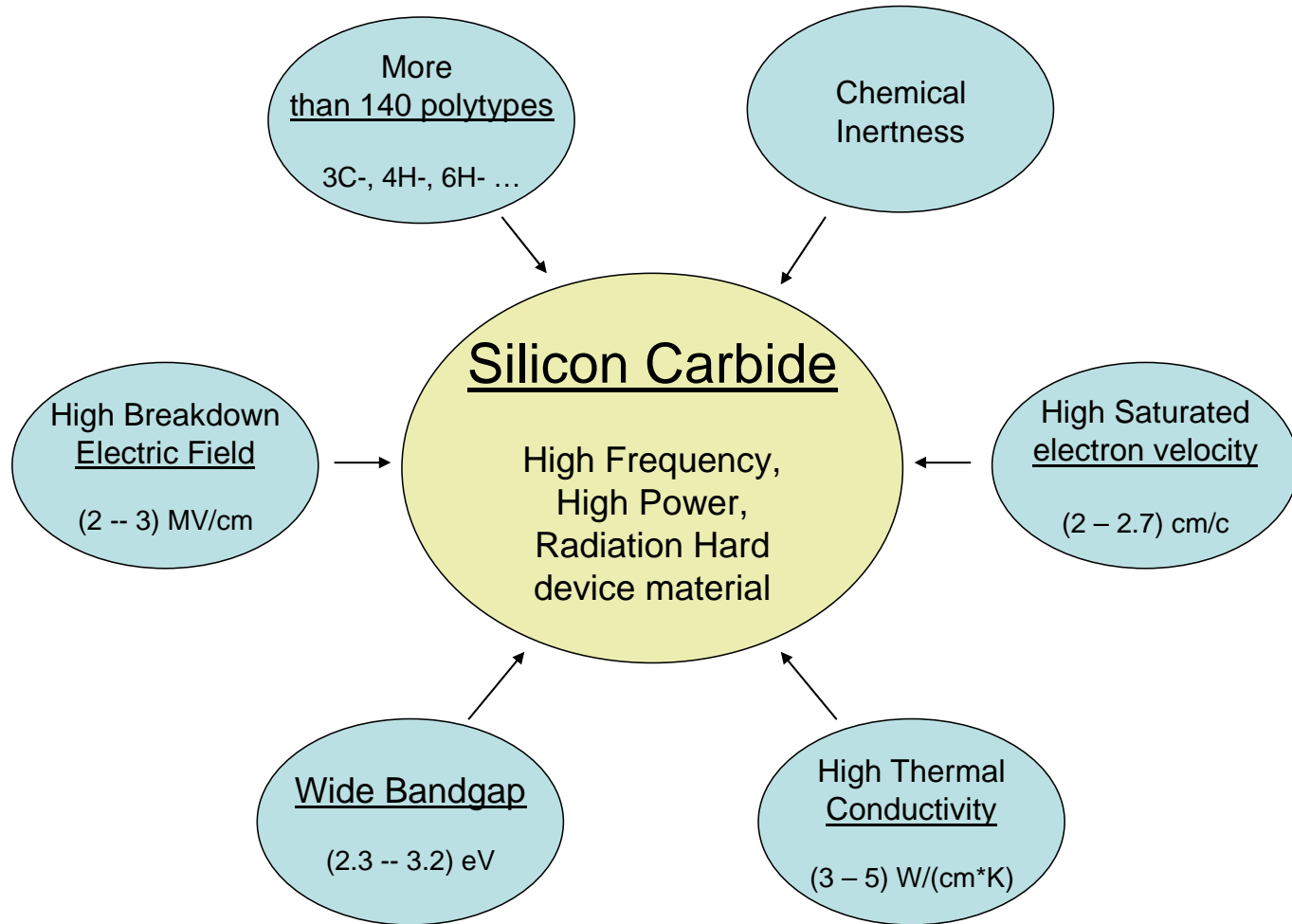


Negative muon spin rotation study of acceptor centers in SiC

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SiC technology: 1) Modified Lely method – substrates (up to 3” in diameter);
2) CVD method – epitaxy.

Donor and acceptor impurities in SiC

Impurity	Type	E_i , mV	Structure
N	shallow donor	50 -- 150	N_C (in-center)
Al	shallow acceptor	240	Al_{Si} (in-center)
B	shallow acceptor	300	B_{Si} (off-center)
Al	deep acceptor	500 – 600	$Al_{Si} + V_C$
B	deep acceptor	600 – 700	$B_{Si} + V_C$

- No ESR-spectra of Al atoms in 3C-SiC were observed;
- No experimental data on the relaxation of the magnetic moment of the Al acceptor;
- No acceptor centers related to a B atom at the C cite were found.

μ SR in SiC -- modelling Al_{Si} and B_C substitutional impurities
by muonic atoms ${}_{\mu}Al$ and ${}_{\mu}B$

Goals: 1) Detect the B_C acceptor

2) Study the relaxation and ionization processes of ${}_{\mu}Al$ and ${}_{\mu}B$

Formation of a muonic atom

Slowing down of μ^- implanted into matter



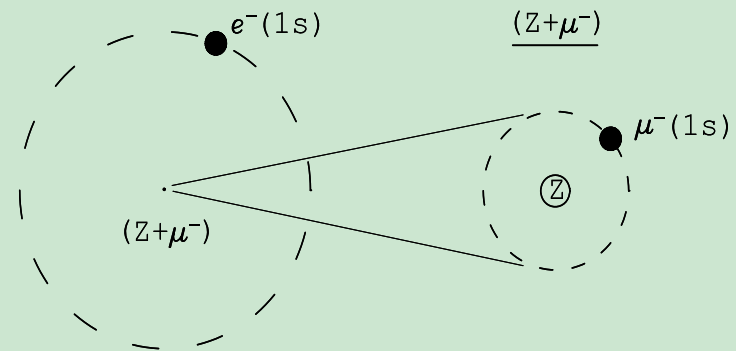
Atomic capture of μ^- : $\mu^- + Z \rightarrow (\mu^- + Z)^*$



De-excitation of the muonic atom

(Auger and radiative transitions of μ^- to the 1S-state)

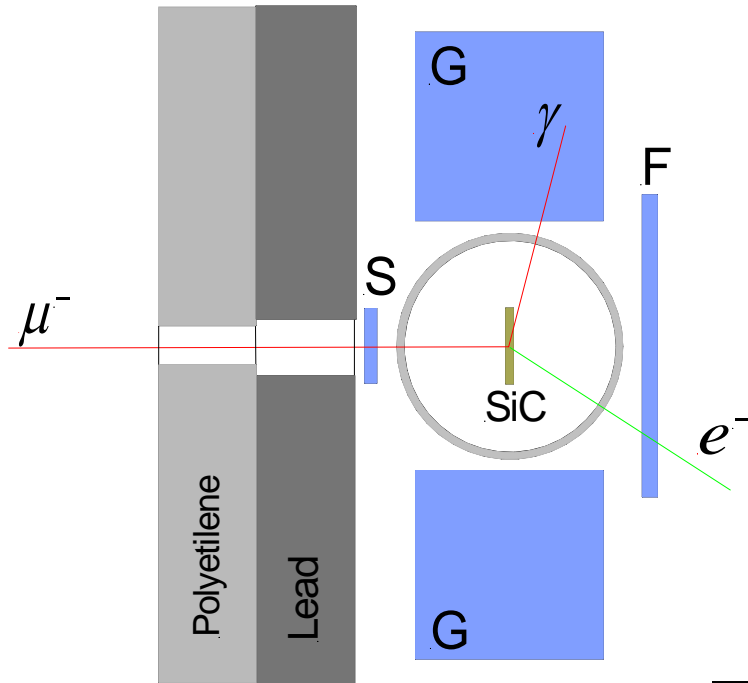
$< 10^{-9}$ s



$$S(Z) = 0 \quad \Rightarrow \quad \begin{aligned} S(Z + \mu^-) &= 1/2 \\ P(Z + \mu^-) &= P(\mu^-) \sim 17\% \end{aligned}$$

SiC: ${}_{\mu}Al$ (760 ns) ${}_{\mu}B$ (2030 ns)

γ -triggered μ^- SR-experiment



S, F – muon and electron counters

G – NaI(Tl) 2" x 2" γ -detectors

Start (Si+C) = S(-F) \implies μ^- SR-spectrum

Start (Si) = SG(-F) \implies γ -trig. μ^- SR-spectrum

Stop = F(-S)

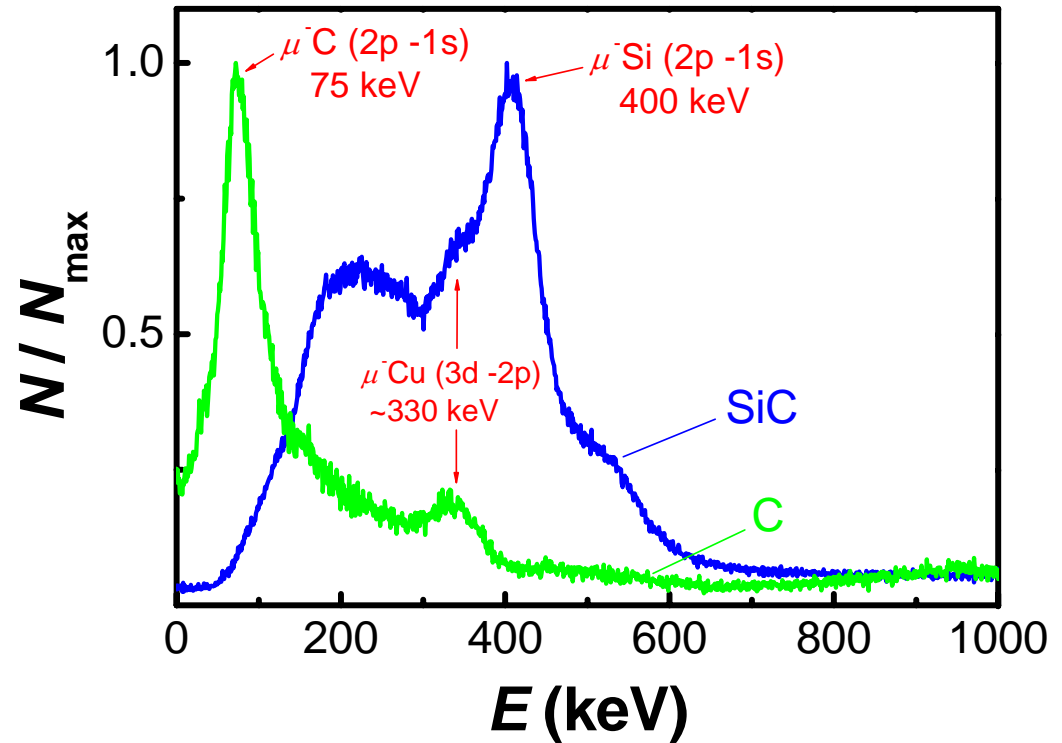
	E_γ (2P \rightarrow 1S) keV	Att. length in Iron mm	Transmission in 2mm Iron %	Overall γ (Si) efficiency %
Si	400	13	85	~10
C	75	2	37	

Sample:

4H-SiC (4x 20x20x0.38 mm³)

n - type (impurity N)

resistivity <0.025 Ohm*cm



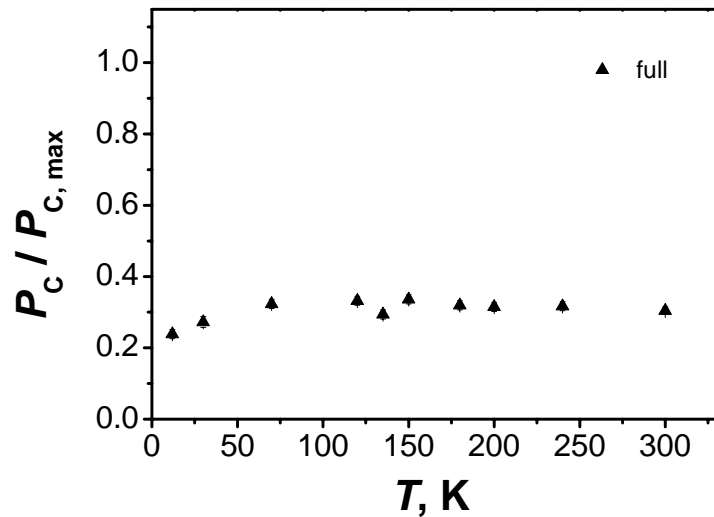
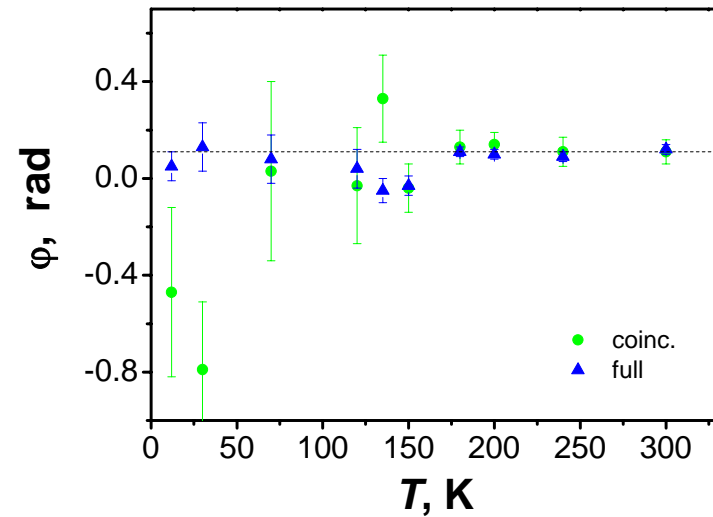
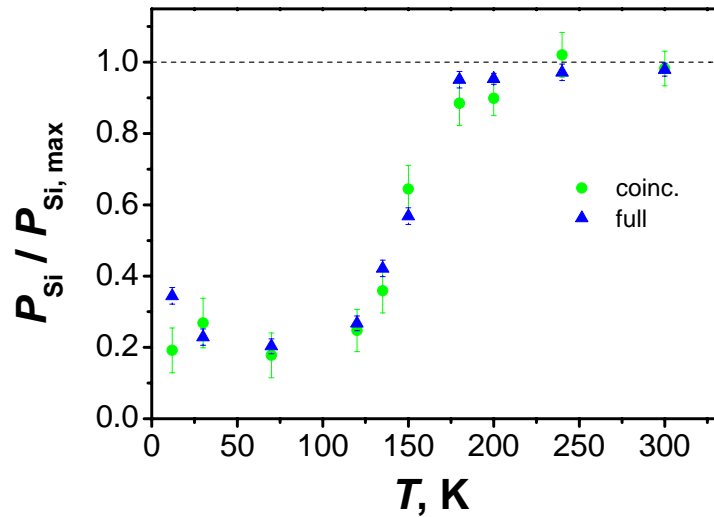
Experimental conditions:

TF, $H = 1\text{kG}$, one γ -detector

Effective solid angle of the γ -detector $\approx 5\%$

Suppression of C-component in **coinc.** spectrum -- 20 times

- Fit: 1) Si, C (RT): $\omega_{\text{Si}}(\text{Si}) = 84.90(2) \text{ rad}/\mu\text{s}$, $\omega_{\text{C}}(\text{C}) = 85.102(8) \text{ rad}/\mu\text{s}$
 2) SiC (coinc.): $\lambda_{\text{Si}} \approx 0$
 3) SiC (full): a) $\lambda_{\text{Si}} = 0$: $\lambda_{\text{C}} \approx 0$, $\omega_{\text{Si}}(\text{SiC}) \approx \omega_{\text{Si}}(\text{Si}) (10^{-3})$, $\omega_{\text{C}}(\text{SiC}) \approx \omega_{\text{C}}(\text{C}) (7 \cdot 10^{-4})$
 b) $\lambda_{\text{Si}} = 0$, $\lambda_{\text{C}} = 0$, $\omega_{\text{Si}}(\text{SiC}) = \omega_{\text{Si}}(\text{Si})$, $\omega_{\text{C}}(\text{SiC}) = \omega_{\text{C}}(\text{C})$



Model:

hydrogen like atom: $S_h = 1/2$

high field limit: $\omega_h = g_h \mu_B H / \hbar \sim 2800 \text{ MHz} \gg \Omega$

Ω – frequency of the hyperfine interaction;

ω_0 – free muon-spin frequency.

$$\frac{d}{dt} P_0 = i\omega_0 P_0 + \nu (P_1 + P_2)$$

$$\frac{d}{dt} P_1 = (i\omega_1 - \nu) P_1$$

$$\frac{d}{dt} P_2 = (i\omega_2 - \nu) P_2$$

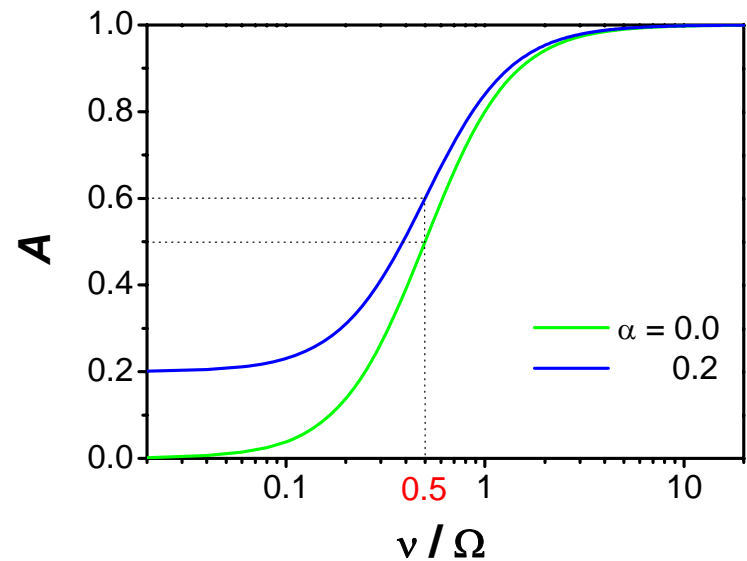
$$\begin{array}{ll} \omega_1 = \omega_0 - \Omega/2 & P_0(0) = \alpha \\ \omega_2 = \omega_0 + \Omega/2 & P_1(0) = P_2(0) = (1 - \alpha)/2 \end{array}$$

$$P_0 = \underbrace{A e^{i\omega_0 t + \phi}}_{\text{observed signal}} + \underbrace{\sum_{k=1}^2 C_k e^{i(\omega_k - \nu)t}}_{\text{not observed at } \Omega/2\pi \geq 500 \text{ MHz}}$$

observed signal

not observed at $\Omega/2\pi \geq 500 \text{ MHz}$

$$A = \alpha + \frac{1 - \alpha}{1 + \left(\frac{\Omega}{2\nu}\right)^2}; \quad \phi = 0$$



Thermal ionization of μAl acceptor

$$\nu = N_V \sigma v_{\text{th}} e^{-E_i/kT}$$

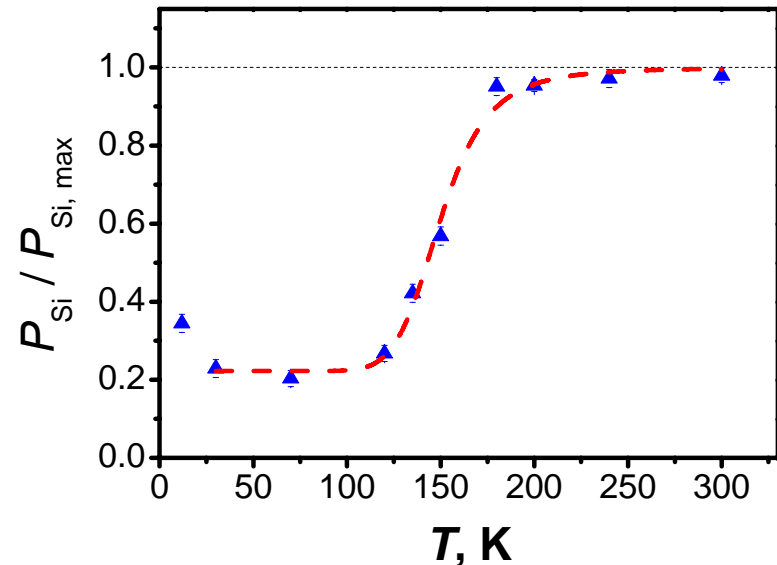
N_V – the density of states in the valence band;
 σ – the cross section for hole capture
 by a negatively charged acceptor;
 v_{th} – the thermal velocity of holes;
 E_i – the acceptor ionization energy.

$$\begin{aligned}
 N_V &= 4.9 \cdot 10^{15} T^{3/2} && \text{at } m_h^* = m_e \\
 v_{\text{th}} &= 6.7 \cdot 10^5 T^{1/2} \\
 \sigma &= \sigma_{100\text{K}} \cdot 10^6 T^{-3}, && \text{i.e } \sigma \sim T^{-3} \quad [1]
 \end{aligned}$$

[1] V.N. Abakumov *et.al*, Sov.Phys.Semicond. 12, 1 (1978)

$$\nu = 3.3 \cdot 10^{27} \sigma_{100\text{K}} T^{-1} e^{-E_i/k_B T}$$

$$\frac{P_{\text{Si}}}{P_{\text{Si,max}}} \equiv A = \alpha + \frac{1 - \alpha}{1 + \left(\frac{\Omega}{2\nu}\right)^2}$$



At $\Omega/2\pi = 500$ MHz

$$\alpha = 0.22 \pm 0.01$$

$$\sigma_{100\text{K}} = (6.5 \pm 3.4) \cdot 10^{-14} \text{ cm}^2$$

$$E_i = \underline{(88 \pm 7) \text{ meV}}$$

Al-acceptor:

$$E_i \approx 240 \text{ meV}$$

Ionization of μAl by electron capture

$$\nu = n_e \sigma v_{\text{th}}$$

n_e – concentration of electrons in the conduction band;

σ – cross section for electron capture

by a neutral μAl acceptor;

v_{th} – thermal velocity of electrons.

$$n_e \approx \frac{1}{\sqrt{2}} (N_d \cdot N_c)^{1/2} e^{-E_d/2 k_B T}$$

N_d – concentration of donor impurities;

N_c – density of states in the conduction band;

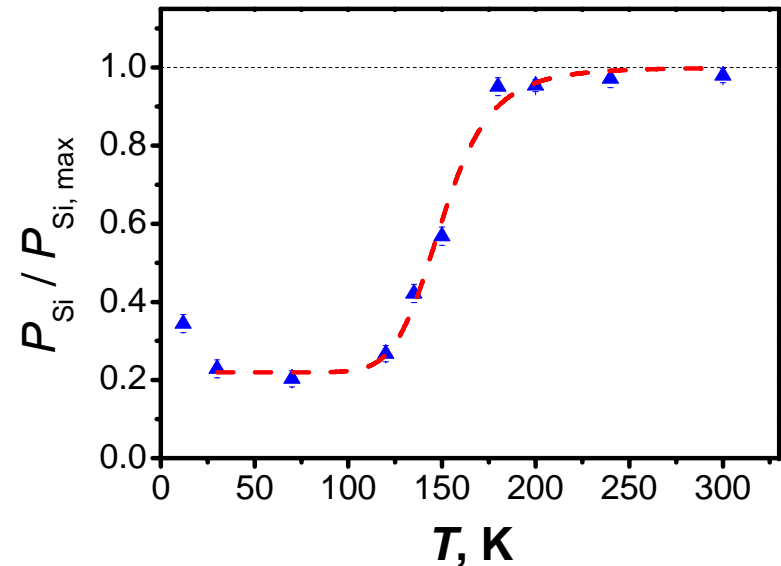
E_d – donor ionization energy.

$$N_c \approx 3.25 \cdot 10^{15} T^{3/2}$$

$$v_{\text{th}} \approx 1.1 \cdot 10^6 T^{1/2}$$

$$\nu = 4.4 \cdot 10^{13} (\sigma N_d^{1/2}) T^{5/4} e^{-E_d/2 k_B T}$$

$$\frac{P_{\text{Si}}}{P_{\text{Si,max}}} \equiv A = \alpha + \frac{1 - \alpha}{1 + \left(\frac{\Omega}{2\nu}\right)^2}$$



$$\alpha = 0.22 \pm 0.01$$

$$\sigma N_d^{1/2} = (5.9 \pm 2.9) \cdot 10^{-6} \text{ cm}^{1/2}, \text{ at } \Omega/2\pi = 500 \text{ MHz}$$

$$E_d = \underline{(115 \pm 13) \text{ meV}}$$

$$\text{N-donor: } E_d = (50 - 150) \text{ meV}$$